

07/03/03
18304 U.S. PTO

PATENT

Attorney Docket No. MICRON.109DC1D1

Date: July 3, 2003

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10/614538

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Mail Stop PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Transmitted herewith for filing is the patent application of

Inventor(s): Gary Chen et al.

For: SEMICONDUCTOR STRUCTURE WITH SUBSTANTIALLY ETCHED OXYNITRIDE DEFECTS

PROTRUDING THEREFROM

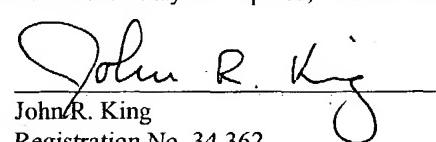
Enclosed are:

- (X) 6 sheets of drawings.
(X) This application is a divisional of U. S. Patent Application 10/234,577, filed on August 30, 2002, the entirety of which is hereby incorporated herein by reference.
(X) A copy of Declaration from prior application is enclosed.
(X) Incorporation by Reference. The entire disclosure of the prior application, from which a copy of the oath or declaration is supplied is considered as being part of the disclosure of the accompanying application and is hereby incorporated by reference therein.
(X) Return prepaid postcard.
(X) An Information Disclosure Statement.
(X) A PTO Form 1449 listing thirty-two (32) references.
(X) Examiner Communication

CLAIMS AS FILED

FOR	NUMBER FILED	NUMBER EXTRA	RATE	FEE
Basic Fee			\$750	\$750
Total Claims	49 - 20 =	29 ×	\$18	\$522
Independent Claims	5 - 3 =	2 ×	\$84	\$168
TOTAL FILING FEE				\$1440

- (X) A check in the amount of \$1440 to cover the filing fee is enclosed.
(X) The Commissioner is hereby authorized to charge any additional fees which may be required, now or in the future, or credit any overpayment to Account No. 11-1410.
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Attorney Docket No. : MICRON.109DC1D1

Applicant(s) : Gary Chen et al.

For : SEMICONDUCTOR STRUCTURE WITH
SUBSTANTIALLY ETCHED OXYNITRIDE
DEFECTS PROTRUDING THEREFROM

Attorney : John R. King

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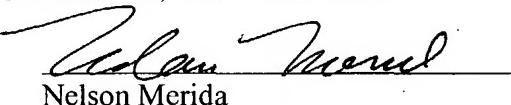
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Date of Deposit : July 3, 2003

I hereby certify that the accompanying

Transmittal letter; specification in 19 pages; 6 sheets of drawings; Examiners Communication, copy of Declaration by Inventor in 2 pages; Information Disclosure Statement, PTO Form 1449 with 32 references; Check(s) for Filing Fee(s); Return Prepaid Postcard

are being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 on the date indicated above and are addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.



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